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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/338,647 01/09/2003 PAT 6,790,677 *yes* *OK*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-056146 03/01/2002 *yes* *OK*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 3	INDEPENDEN CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>J. Kennedy</i> Initials <i>JK</i>				

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## TITLE

Method of forming a ferroelectric film and fabrication process of a semiconductor device having a ferroelectric film

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